



1765  
JFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Small et al.  
Title: Compositions for Chemical-Mechanical Planarization of Copper  
Serial No.: 10/017,934 Filing Date: December 12, 2001  
Examiner: Umez Eronini, Lynette T.. Group Art Unit: 1765  
Docket No.: CHEM.001US0 Conf. No.: 1435

Certificate of Mailing Under 37 CFR 1.8

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Gailen Bow  
Signature

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT**

Sir:

This is in response to a Notice of Non-Compliant Amendment that was mailed on August 18, 2004, and set a shortened statutory period for response that expires on September 18, 2004. In view of the following response and the amendment of the specification, as set forth herein, reconsideration is respectfully requested.